In the Specification:

On page 1 lines 1 and 2, please amend the Title of the Invention as follows:

TRAILING EDGE TAPER DESIGN AND METHOD FOR MAKING A PERPENDICULAR WRITE HEAD WITH SHIELDING

On page 19 lines 1 and 2, please amend the Title of the Invention as follows:

TRAILING EDGE TAPER DESIGN AND METHOD FOR MAKING A PERPENDICULAR WRITE HEAD WITH SHIELDING

On page 19, please amend the Abstract as follows:

A magnetic write head for us use in perpendicular magnetic data recording. The write head includes a write pole and a trailing shield having a tapered surface. A return pole stitched to the trailing shield is magnetically connected with the write pole at a location away from the air bearing surface (ABS).

Please amend the paragraph beginning on page 10, line 20 as follows:

With reference now to Fig. 6, a REI RIE process may be performed to remove portions of the Ta layer 510 and 508. Preferably the REI RIE process is performed at an angle as shown, so that the shadowing effect of the mask will promote a tapered removal of material also as shown. Since as mentioned above, the first magnetic pole

layer 506 is constructed of a material that is not as readily removed by RIE, the surface will tend flatten out when that surface is reached and at that point the RIE process should be stopped.